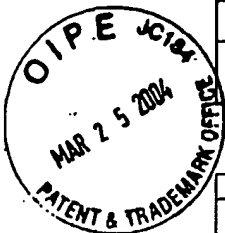


First Named Inventor	Ravi Iyer	<b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT FORM PTO-1449</b>
Serial No.	10/689,894	
Filing Date	October 21, 2003	
Group Art Unit	2822	
Examiner Name	Unknown	
Attorney Docket No.	400.083US03	
Title: COMPOUND STRUCTURE FOR REDUCED CONTACT RESISTANCE		Sheet 1 of 1






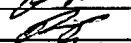


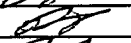

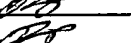


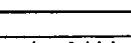
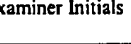
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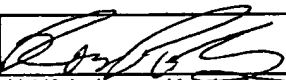
Examiner Signature	<i>Ravi Iyer</i>	Date Considered	12/13/05
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			

First Named Inventor	Ravi Iyer	<b>INFORMATION DISCLOSURE STATEMENT FORM PTO-1449</b>
Serial No.	Unknown	
Filing Date	Herewith	
Group Art Unit	Unknown	
Examiner Name	Unknown	
Confirmation No.	Unknown	
Attorney Docket No.	400.083US03	
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Examiner Signature		Date Considered	12/13/05
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